

Appl. No. : 10/807,129  
Filed : March 24, 2004

### AMENDMENTS TO THE CLAIMS

Claims 1-12 were pending prior to the entry of these amendments. Please amend Claims 1, 5, and 9-11.

1. **(Currently Amended)** An optical interference display unit at least comprising:  
a first electrode;  
a second electrode, in parallel with the first electrode and comprising:  
a first material layer; and  
a conductive layer on the first material layer; and  
a support structure partially covered by the second electrode and supporting **[[a]]**  
an edge of the second electrode;  
wherein a material of the conductive layer is more difficult to etch ~~etched~~ than a  
material of the first material ~~layer~~ layer.
2. **(Original)** The optical interference display unit of claim 1, wherein the optical  
interference display unit is located on a substrate.
3. **(Original)** The optical interference display unit of claim 2, wherein the substrate  
is a transparent substrate.
4. **(Original)** The optical interference display unit of claim 1, wherein a material of  
the first electrode is a conductive transparent material.
5. **(Currently Amended)** The optical interference display unit of claim 4, wherein  
the conductive transparent material is indium tin oxide (ITO), indium zinc oxide (IZO), or  
indium oxide **[[ (10) ]]** (IO).
6. **(Original)** The optical interference display unit of claim 1, wherein the second  
electrode is a deformable electrode.
7. **(Original)** The optical interference display unit of claim 1, wherein the second  
electrode is a movable electrode.
8. **(Original)** The optical interference display unit of claim 1, wherein a material for  
forming the support structure is selected from a group consisting of positive photoresist, negative  
photoresist, acrylic resin and epoxy resin.

Appl. No. : 10/807,129  
Filed : March 24, 2004

9. **(Currently Amended)** The optical interference display unit of claim 1, wherein the first material layer is made from a conductive material.

10. **(Currently Amended)** The optical interference display unit of claim 1, wherein the first material layer is made from dielectric material.

11. **(Currently Amended)** The optical interference display unit of claim 9, wherein a material for forming the first material layer is aluminum, chromium, cobalt, copper, silicon nitride or silicon oxide.

12. **(Previously Presented)** The optical interference display unit of claim 1, wherein a material for forming the conductive layer is aluminum, chromium, cobalt, copper, silicon nitride or silicon oxide.

13.-21. **(Canceled)**